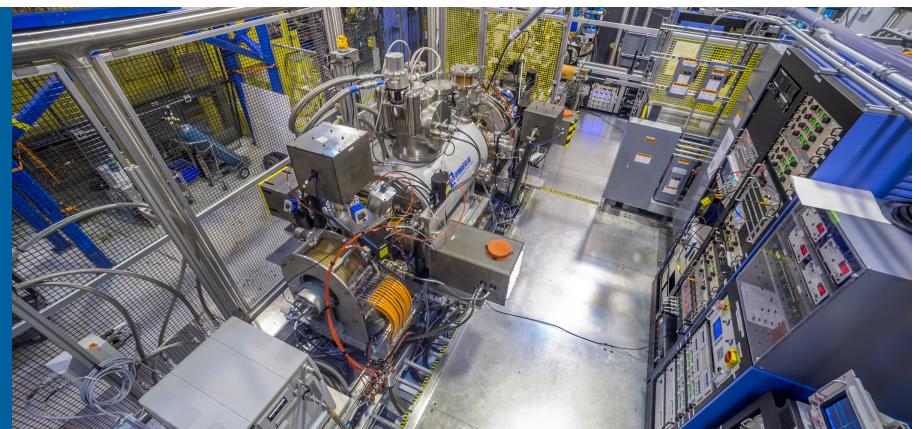


OCTOBER 23, 2018



OPERATIONAL COMPARISON OF AN ECR AND AN EBIS CHARGE BREEDER FOR CARIBU



RICHARD VONDRASEK
Argonne National Laboratory
Physics Division



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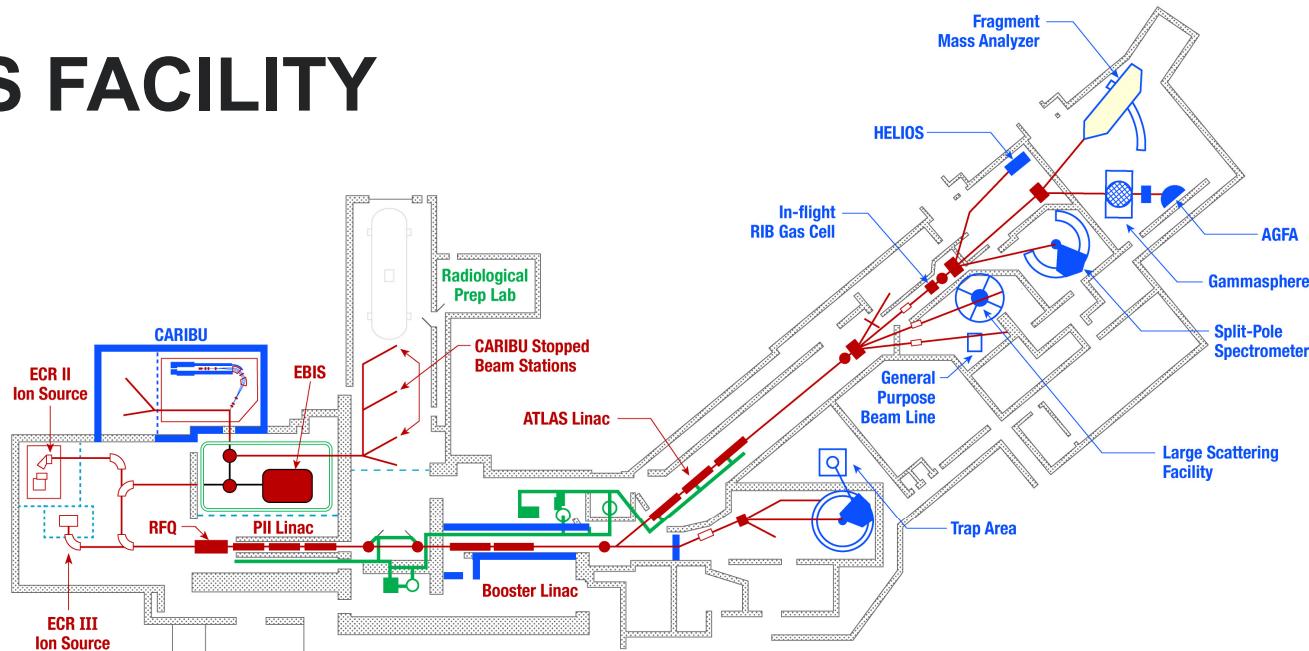
OUTLINE

- ATLAS and CARIBU
- Past ECR-CB performance
- On going efforts to reduce stable background
- Present EBIS-CB performance
- Comparison with ECR-CB
- Future plan



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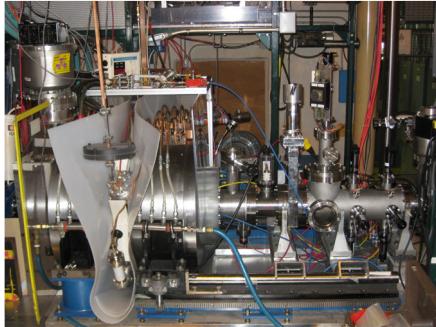
ATLAS FACILITY



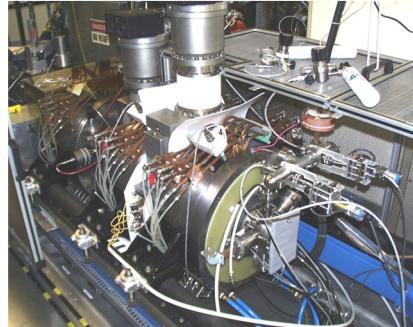
- ATLAS is a National User Facility delivering stable, low energy, ion beams with a focus on nuclear physics research
- ATLAS has a rich history of radioactive beam research
 - Irradiated source materials
 - In-flight beam production
 - CARIBU – reacceleration of Cf fission fragments

ATLAS FACILITY

Front end

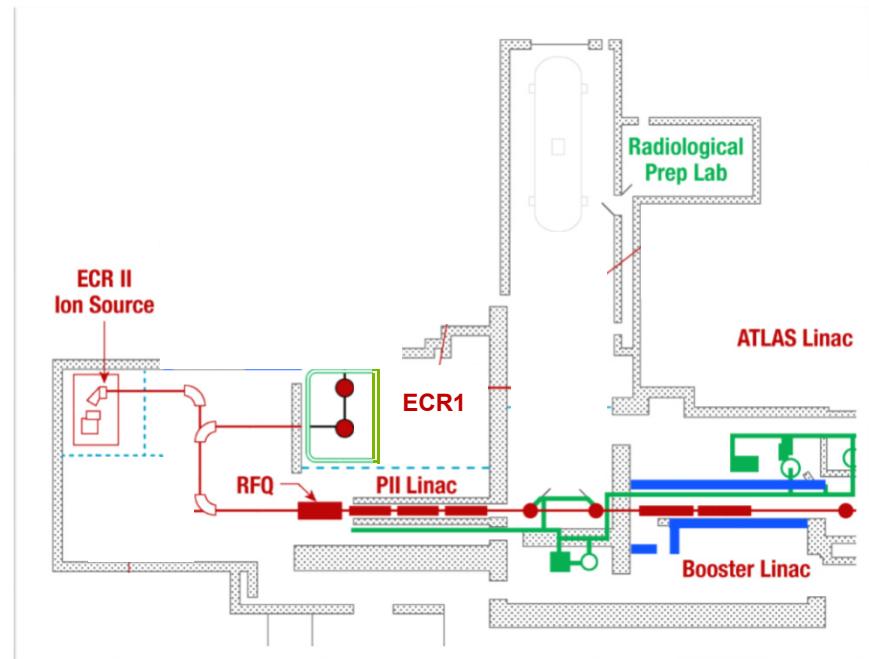


ECR1



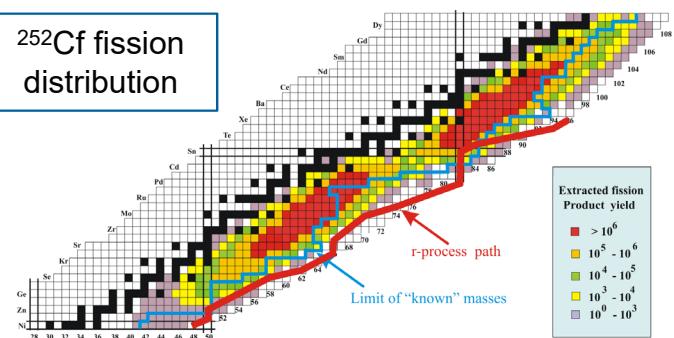
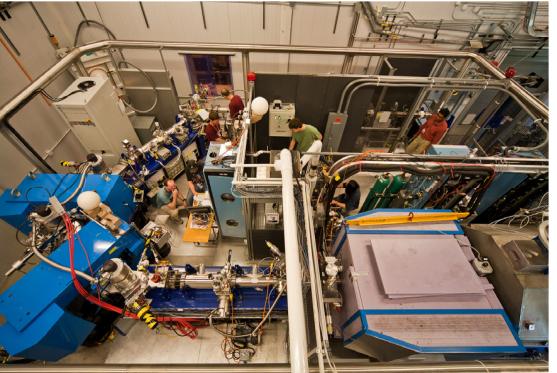
ECR2

- Delivering beams for low-energy nuclear physics research for over 30 years
- In 2005 launched a project expanding our reach into radioactive nuclei near the r-process pathway



CARIBU

Californium Rare Ion Breeder Upgrade



 U.S. DEPARTMENT OF
ENERGY

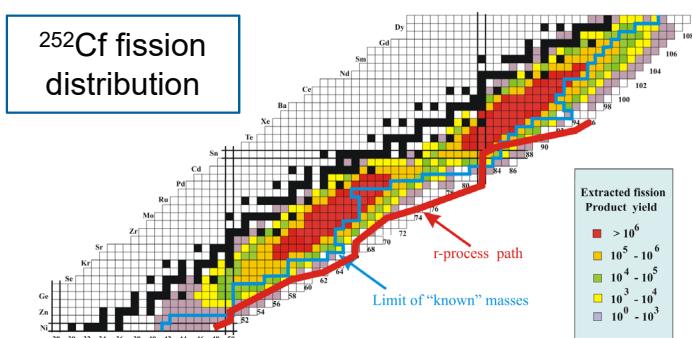
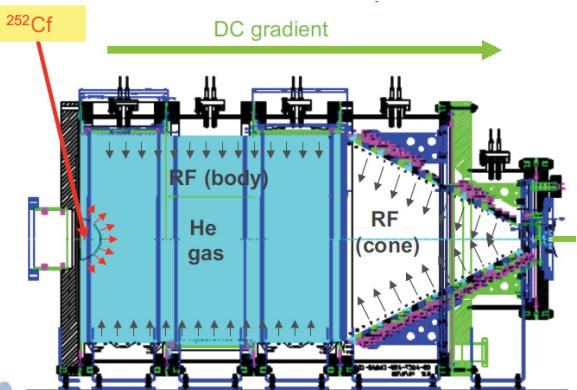
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- ^{252}Cf fission source provides radioactive species
 - 500 mCi source installed 2018
 - Effectively 150 mCi due to thickness
 - Fission fragments are thermalized in a large volume helium gas catcher with RF and DC carpets and extracted as 1+ or 2+ ions
 - Isobar separator - 1:20,000 resolution
 - For the stopped beams
 - RFQ cooler/buncher and MR-TOF
 - What to use in order to raise the charge state to something the linac could accept
 - ECR or EBIS

Argonne
NATIONAL LABORATORY

CARIBU

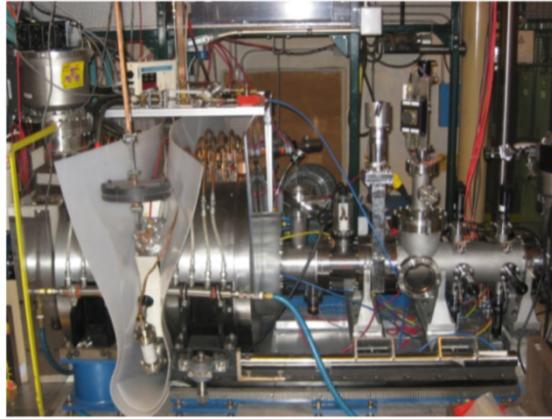
Californium Rare Ion Breeder Upgrade



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- ^{252}Cf fission source provides radioactive species
 - 500 mCi source installed 2018
 - Effectively 150 mCi due to thickness
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- Isobar separator - 1:20,000 resolution
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 - RFQ cooler/buncher and MR-TOF
- What to use in order to raise the charge state to something the linac could accept
 - ECR or EBIS

GENERAL COMPARISON – ECR vs. EBIS



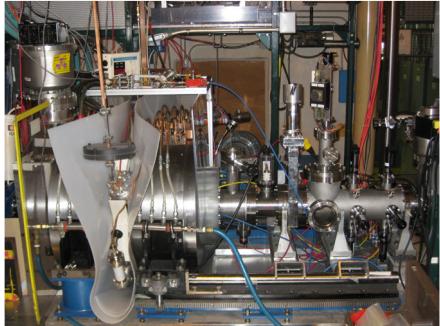
ECR

24%	Best Efficiency	32%
4 - 8	A/Q	2.2 – 5.5
10-20 ms/q	Breeding time	10 - 100 ms (total)
> pA	Contamination	< pA
pμA ($\sim 10^{13}$ pps)	Maximum injected beam	pnA ($\sim 10^{10}$ pps)
CW or pulsed	Mode of operation	Pulsed

EBIS

ATLAS FACILITY

Front end - 2008



ECR-CB



ECR2

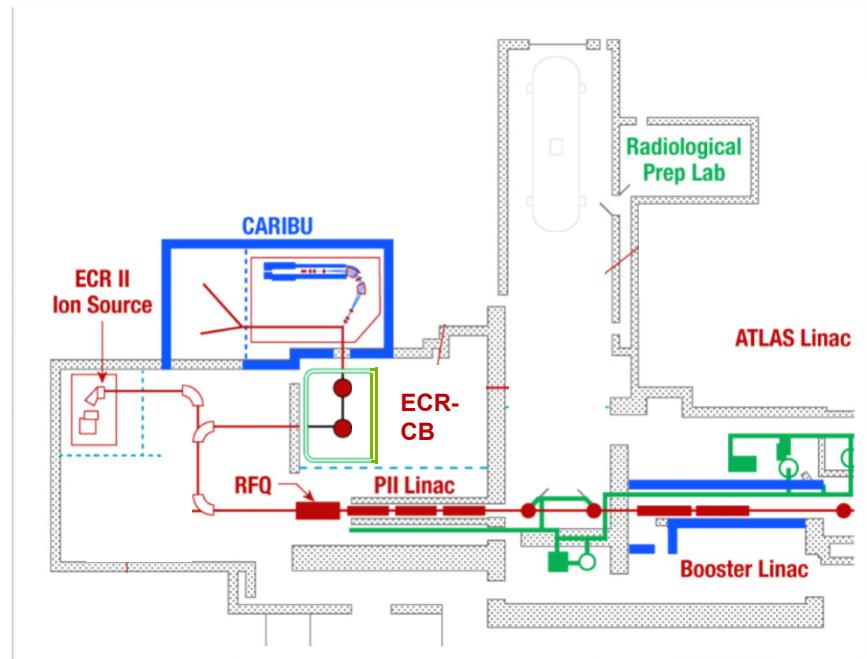


CARIBU



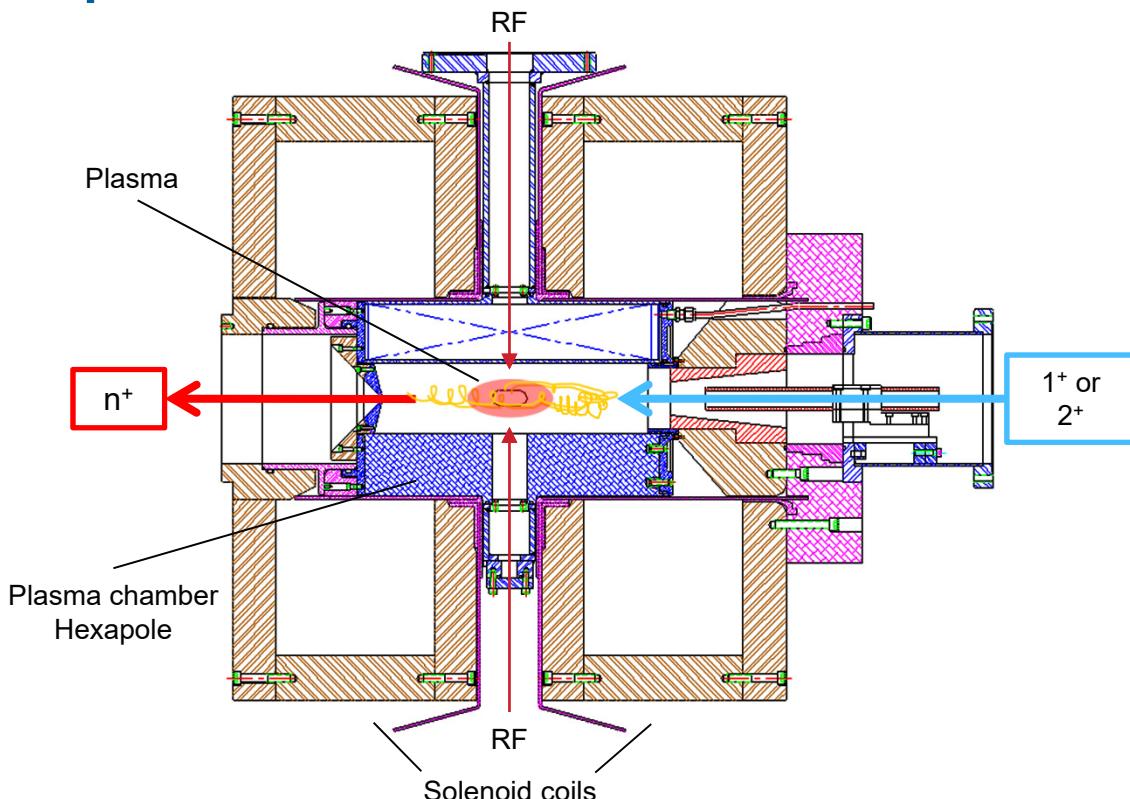
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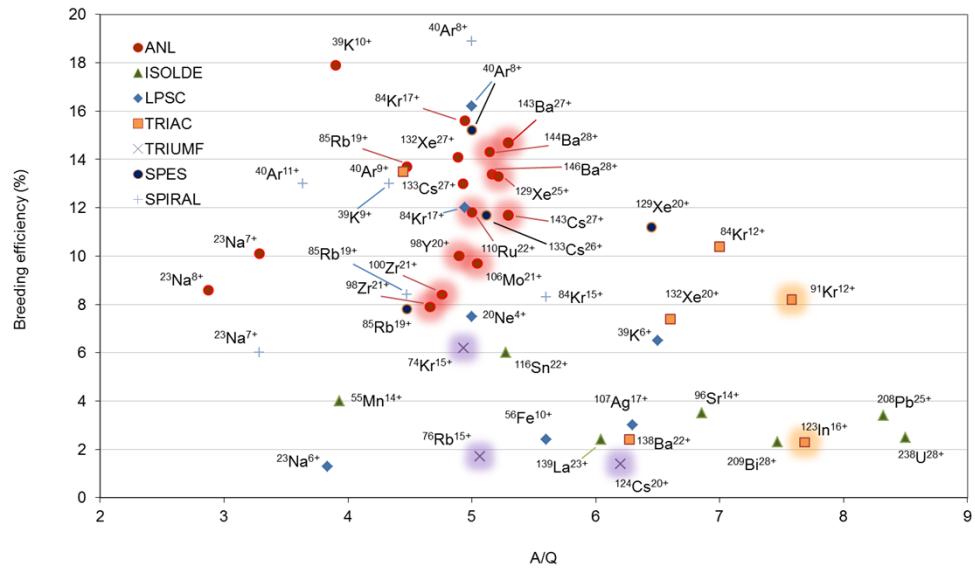
ECR CHARGE BREEDER

Operational 2008-2015



- Solenoid coils provide axial confinement
- Permanent magnet hexapole provides radial confinement
 - Open hexapole
 - Symmetric iron
 - Direct pumping of plasma chamber
- Plasma excited by multiple frequencies in the 10-14 GHz range and <500 W total power
- Step-wise ionization via collisions with energetic electrons

ECR CHARGE BREEDER PERFORMANCE



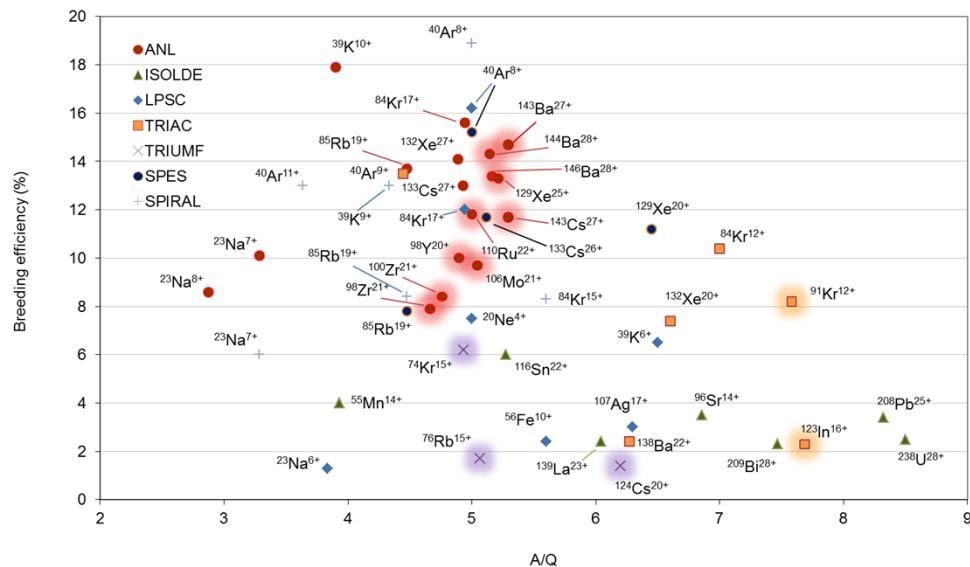
Worldwide ECR charge breeding as of 2017



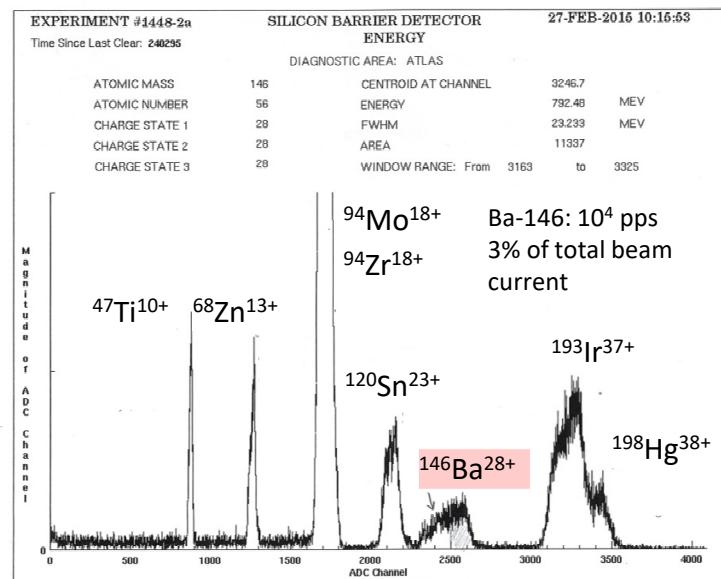
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ECR CHARGE BREEDER PERFORMANCE



Worldwide ECR charge breeding as of 2017

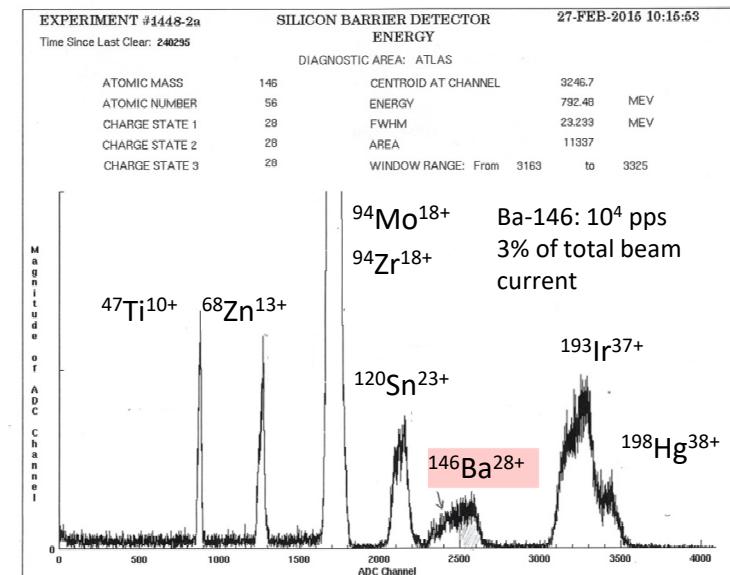


Contamination of RIB with stable background

STABLE BACKGROUND

Sources

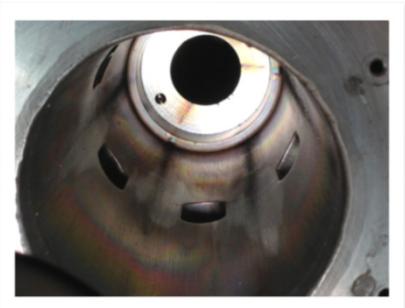
- Foremost mechanisms
 - O-ring permeation
 - Chamber surfaces
 - Bulk materials
 - Plasma chamber
 - Grounded tube
 - Extraction plate
 - RF waveguides
- LEBT discrimination is 1:400
 - Many species were closer than 1:1000
 - Only solution was to eliminate contamination at the ion source



Contamination of RIB with stable background

STABLE BACKGROUND

Mitigation - clean and cover



Chamber before cleaning

*Established a baseline for
F, Cl, Fe at ECR source as
well as Mo beam on target
detector*

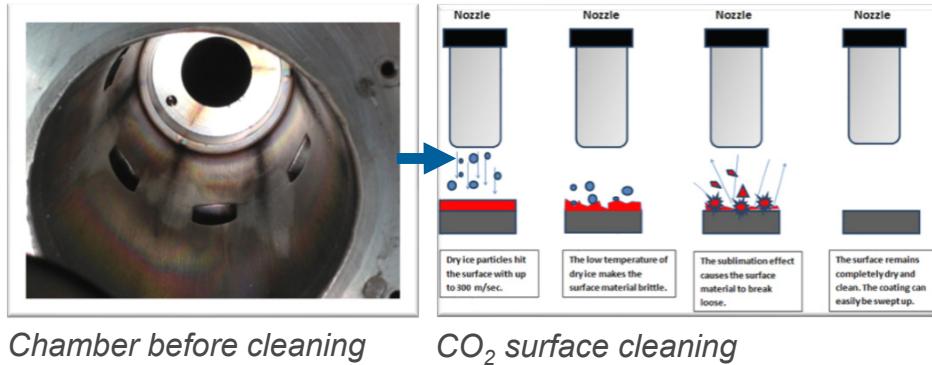


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STABLE BACKGROUND

Mitigation - clean and cover

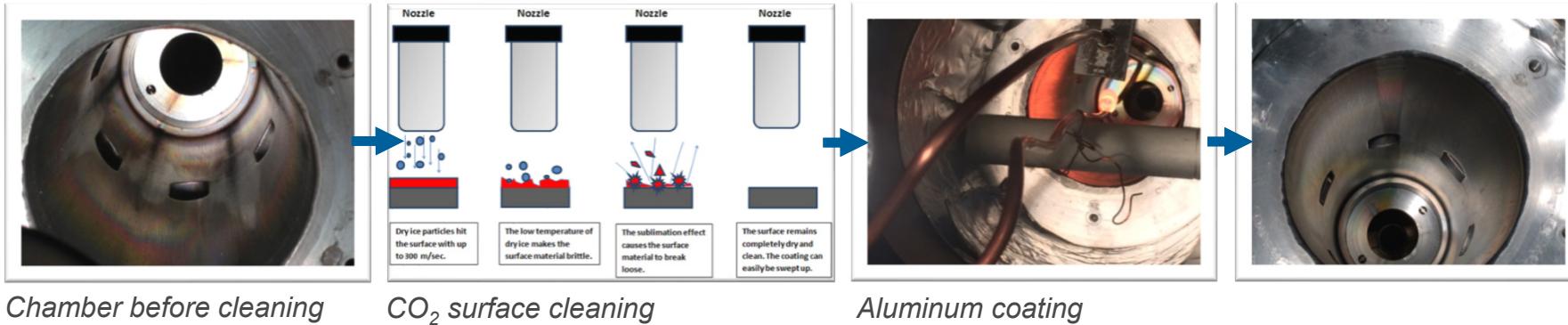


Established a baseline for F, Cl, Fe at ECR source as well as Mo beam on target detector

F: factor of 20 reduction
Cl: factor of 4 reduction
Fe: factor of 50 reduction

STABLE BACKGROUND

Mitigation - clean and cover



Chamber before cleaning

CO_2 surface cleaning

Aluminum coating

Established a baseline for
F, Cl, Fe at ECR source as
well as Mo beam on target
detector

F: factor of 20 reduction
Cl: factor of 4 reduction
Fe: factor of 50 reduction

F: factor of 160 reduction
Cl: factor of 17 reduction
Fe: not detectable
Mo: factor of 5 reduction

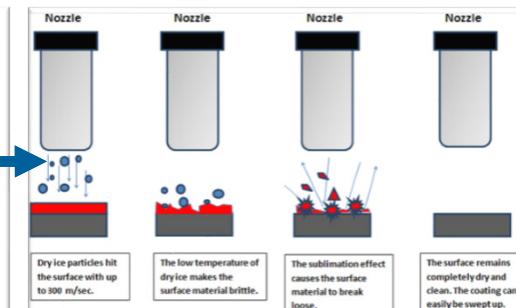
Contaminants of Ta and W
introduced by heating
element

STABLE BACKGROUND

Mitigation - clean and cover

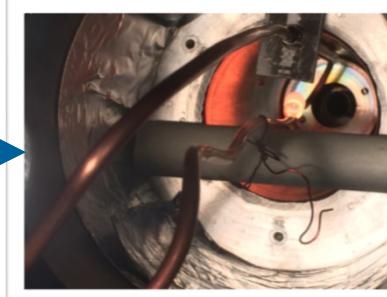


Chamber before cleaning



CO₂ surface cleaning

Established a baseline for F, Cl, Fe at ECR source as well as Mo beam on target detector



Aluminum coating



Some areas not coated

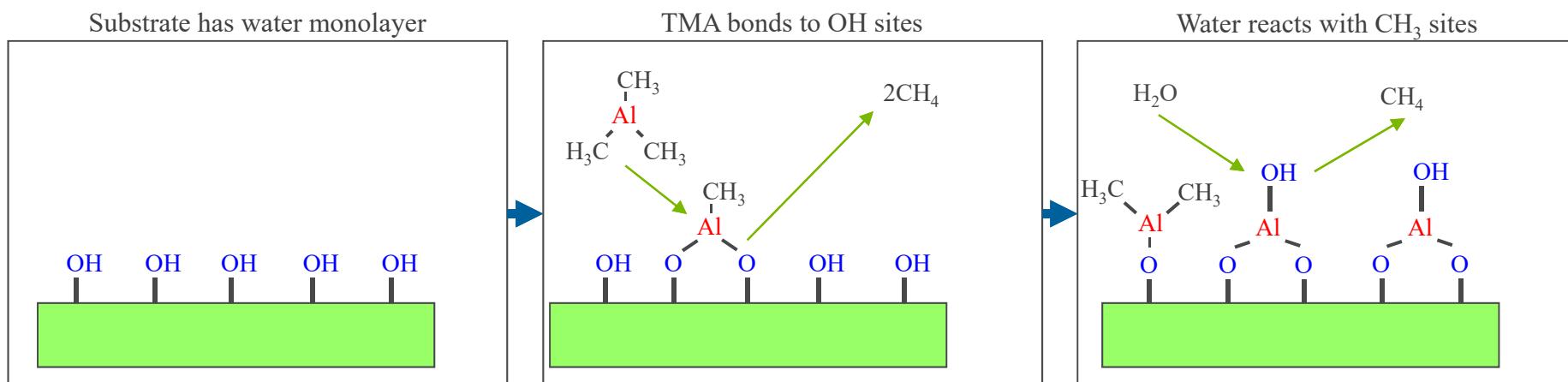
F: factor of 20 reduction
Cl: factor of 4 reduction
Fe: factor of 50 reduction
Mo: factor of 5 reduction

Contaminants of Ta and W introduced by heating element

ATOMIC LAYER DEPOSITION

A better way to coat with aluminum?

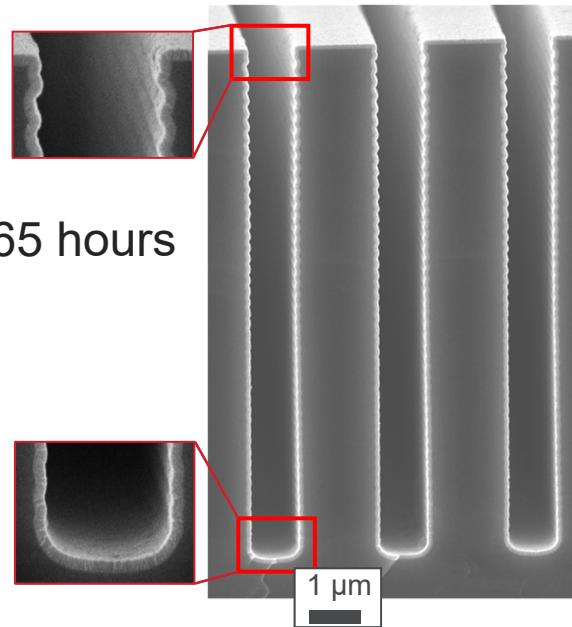
- Thin-film deposition technique based on the use of a gas-phase chemical process
- Two chemicals react with the substrate in a sequential and self-limiting fashion
- Thin film is slowly deposited over the course of successive exposures
- For Al_2O_3 the chemical precursor is trimethylaluminum $\text{Al}(\text{CH}_3)_3$ (TMA)



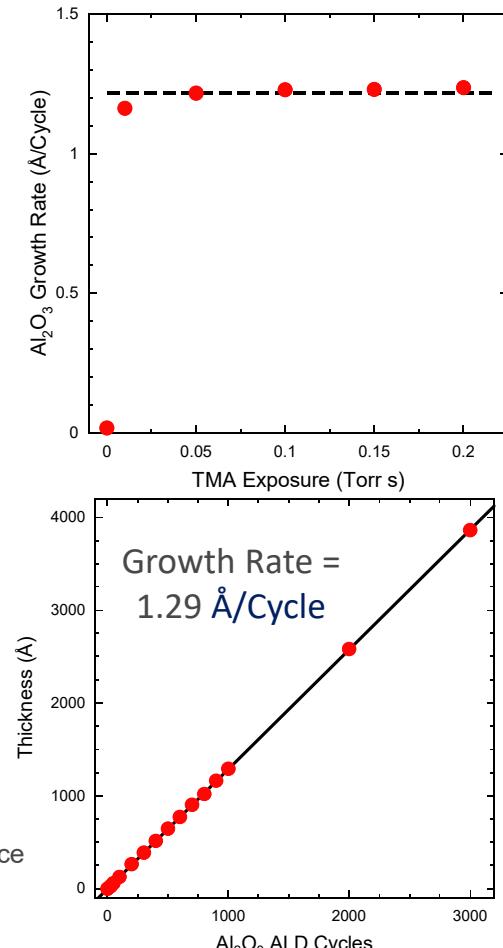
ATOMIC LAYER DEPOSITION

Characteristics

- Conformal
- Self-terminating
- Linear film thickness
 - 1 micron: 7752 cycles, 65 hours
- In situ
- No hot filament
- High purity materials
- Outstanding questions
 - Effectiveness
 - Longevity
 - Tests with ECR3 ion source



J. Lu, J. W. Elam, and P. C. Stair, Surface Science Reports, **71**, 410-472, (2016)



ATLAS FACILITY

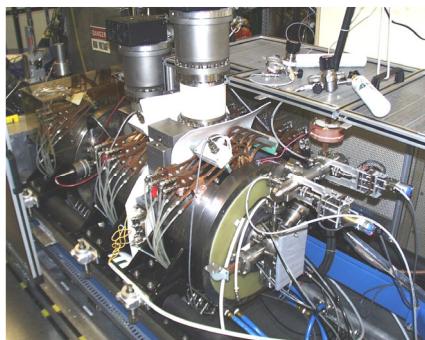
Front end – present day



CARIBU



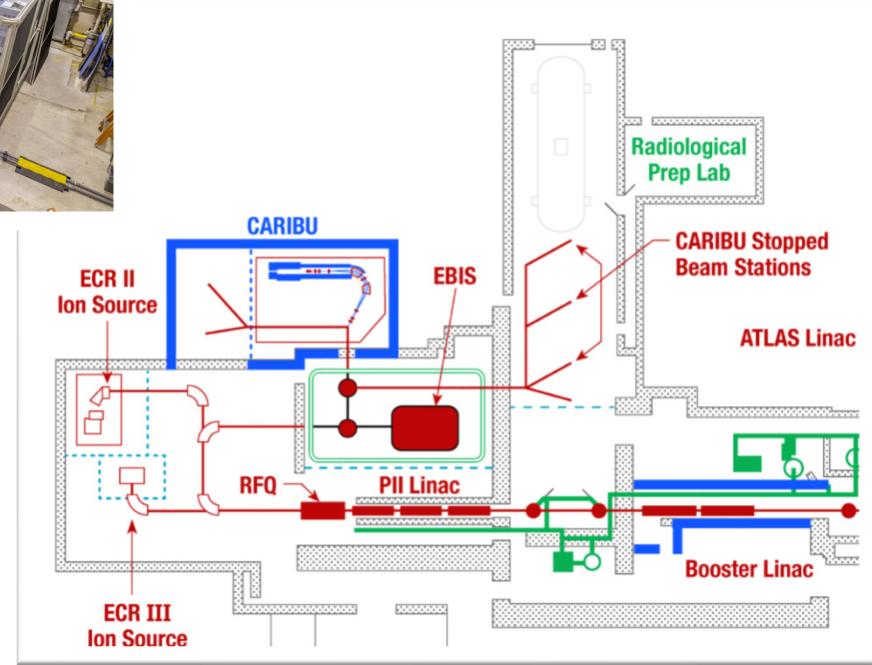
EBIS-CB



ECR2



ECR3



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EBIS CHARGE BREEDER

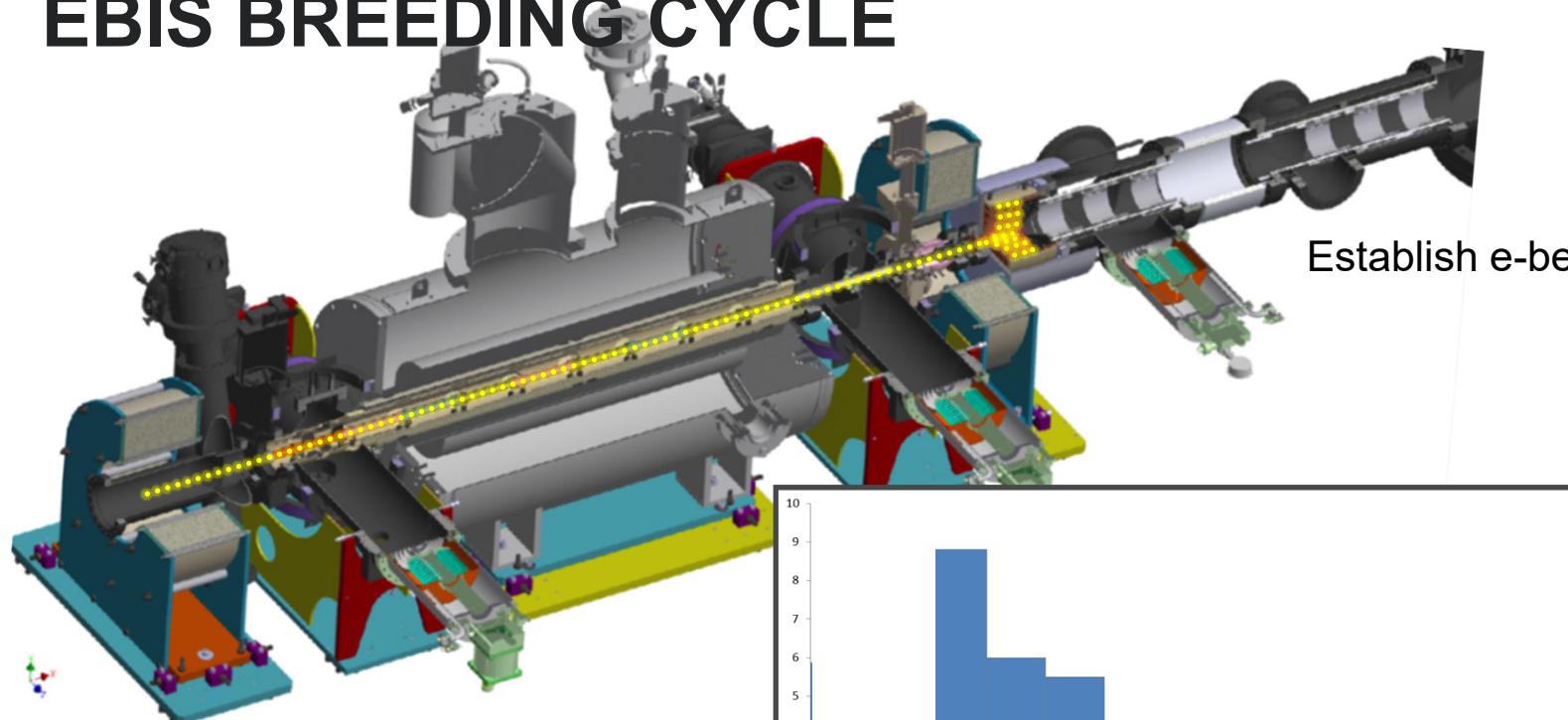
- Developed in collaboration with BNL and is based upon the TestEBIS design
- October 2015 – Replaced the ECR-CB at the ATLAS front end
- September 9, 2016 - First accelerated radioactive charge bred beam (^{142}Cs)



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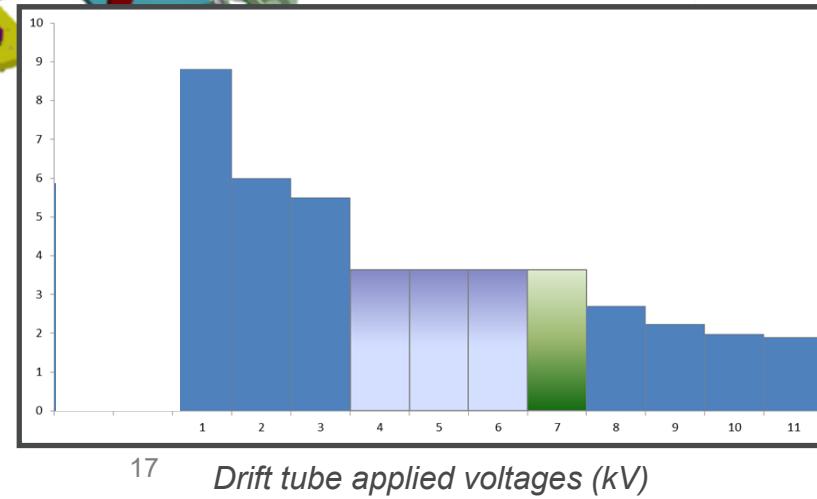
EBIS Operating Parameters	
Solenoid field	5.5 T
Magnetic field on cathode	0.15 T
IrCe cathode diameter	4.2 mm
Electron beam current	1.12 A
Electron beam diameter in trap	0.692 mm
Electron beam density in trap	296 A/cm ²
Electron beam energy in trap	8118 eV
Trap length	0.532 m
Trap capacity	11 nC
Injection time	10-40 μs
Repetition rate	10 Hz
Duty cycle	33 %
EBIS bias	20 kV
Pressure	1×10^{-10} Torr

EBIS BREEDING CYCLE

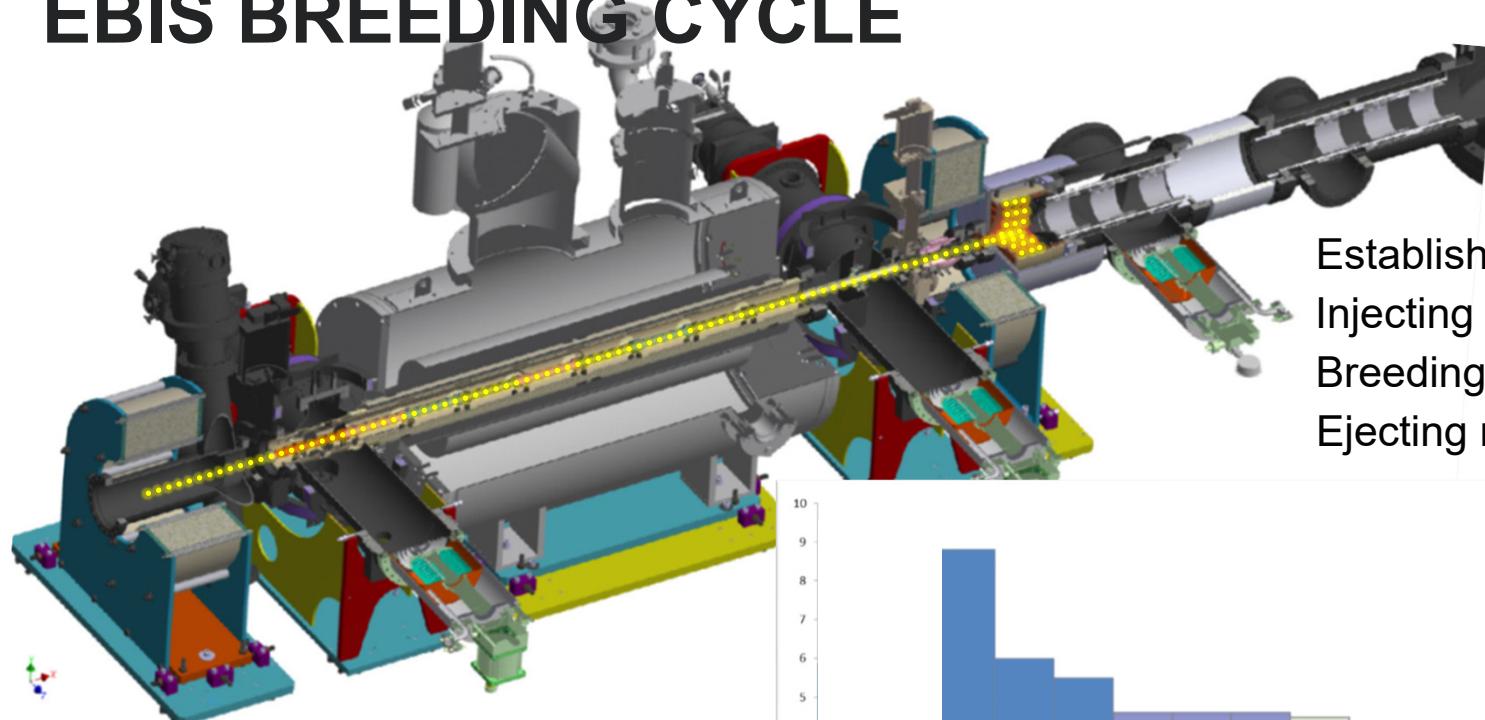


Establish e-beam: 0→1 ms

- Trap electrodes provide axial ion confinement
- Electron beam provides radial ion confinement
- Strong solenoid for electron beam compression
- Interaction with e-beam produces HCl

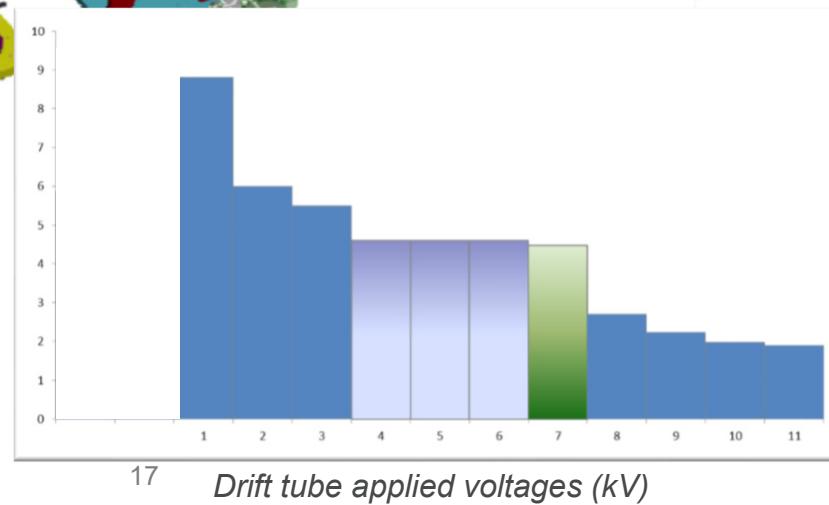


EBIS BREEDING CYCLE

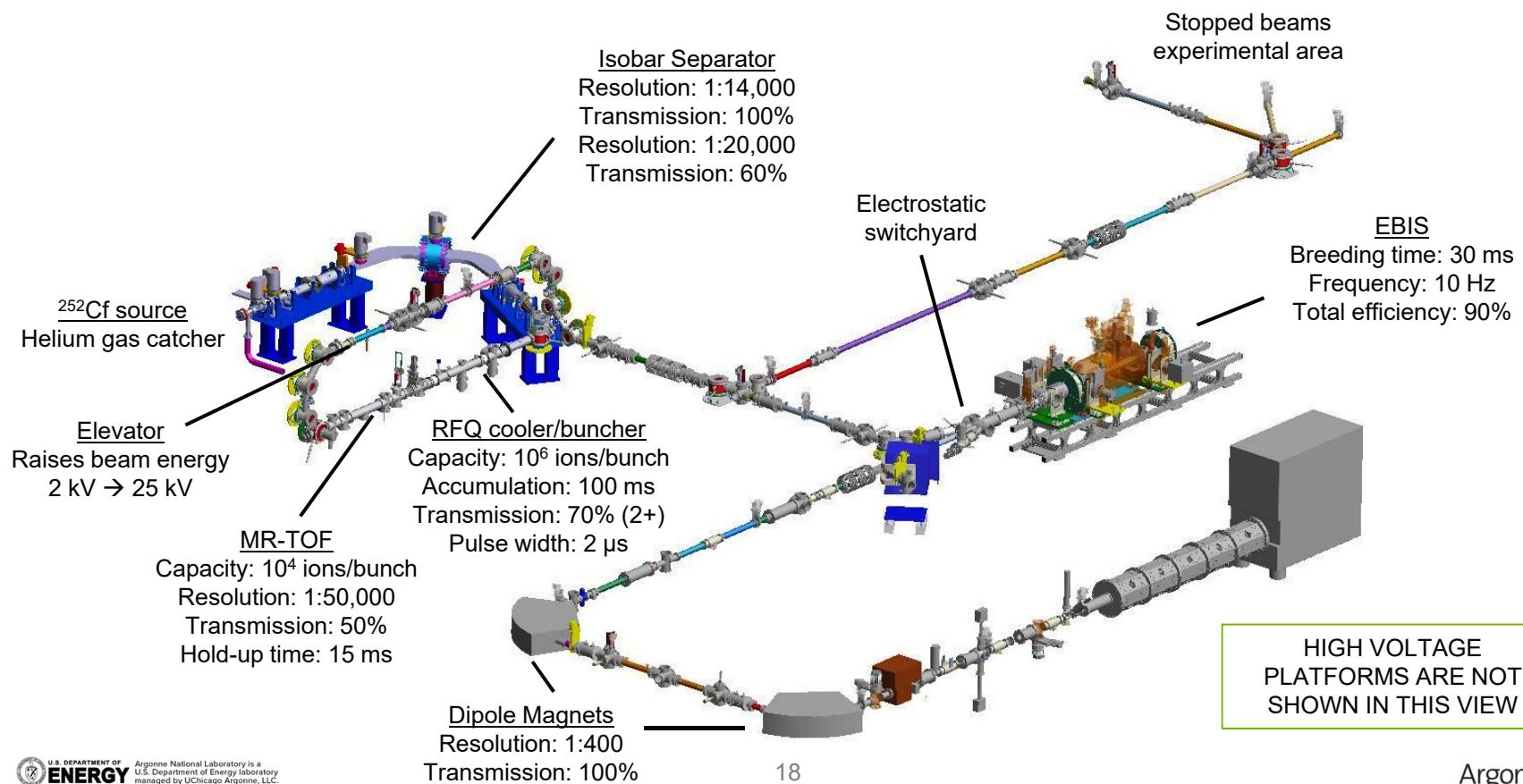


Establish e-beam: 0→1 ms
Injecting 1+ ions: 1→1.1 ms
Breeding to n+: 1.1→30 ms
Ejecting n+ ions: 30→33 ms

- Trap electrodes provide axial ion confinement
- Electron beam provides radial ion confinement
- Strong solenoid for electron beam compression
- Interaction with e-beam produces HCl



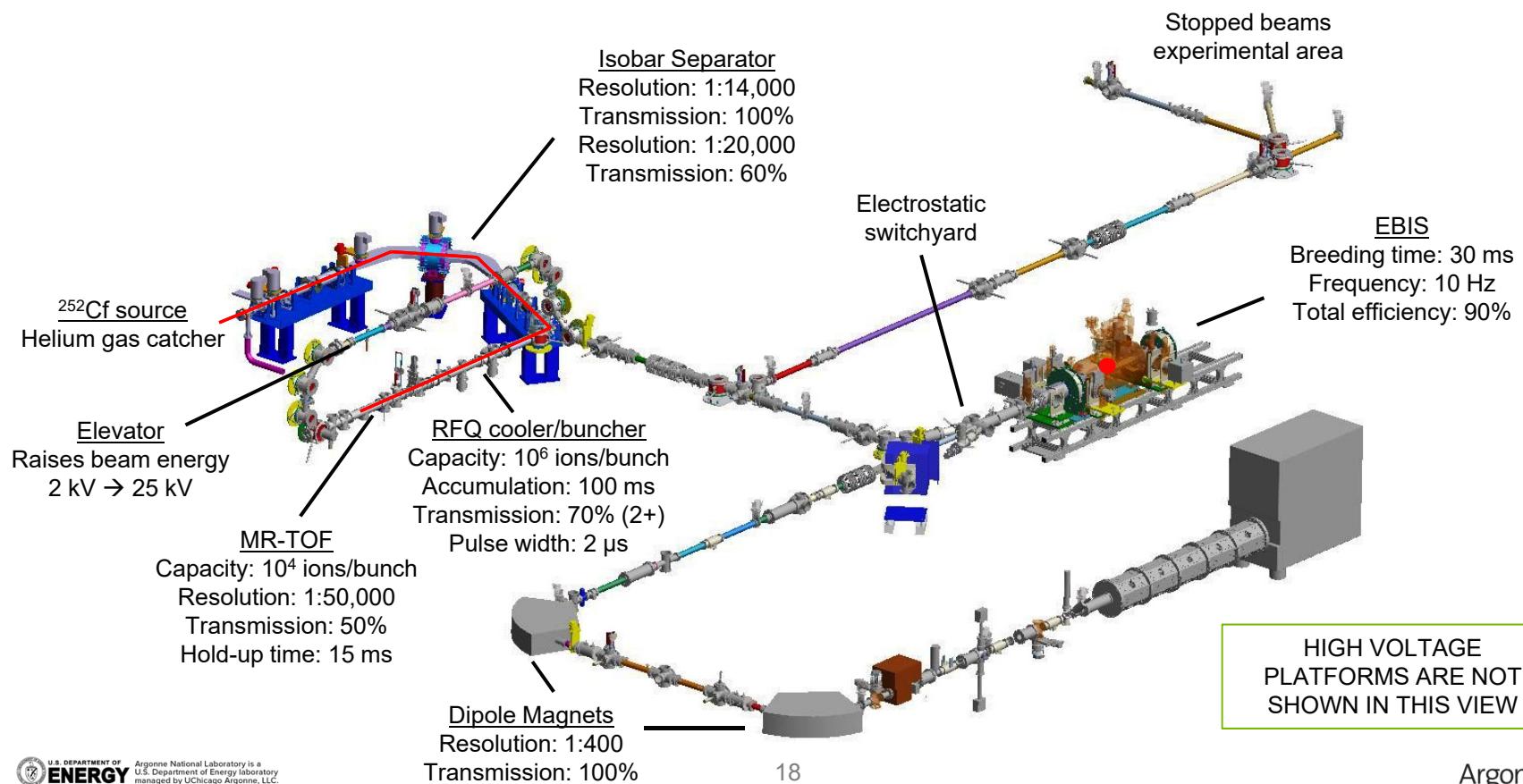
EBIS CHARGE BREEDING CYCLE



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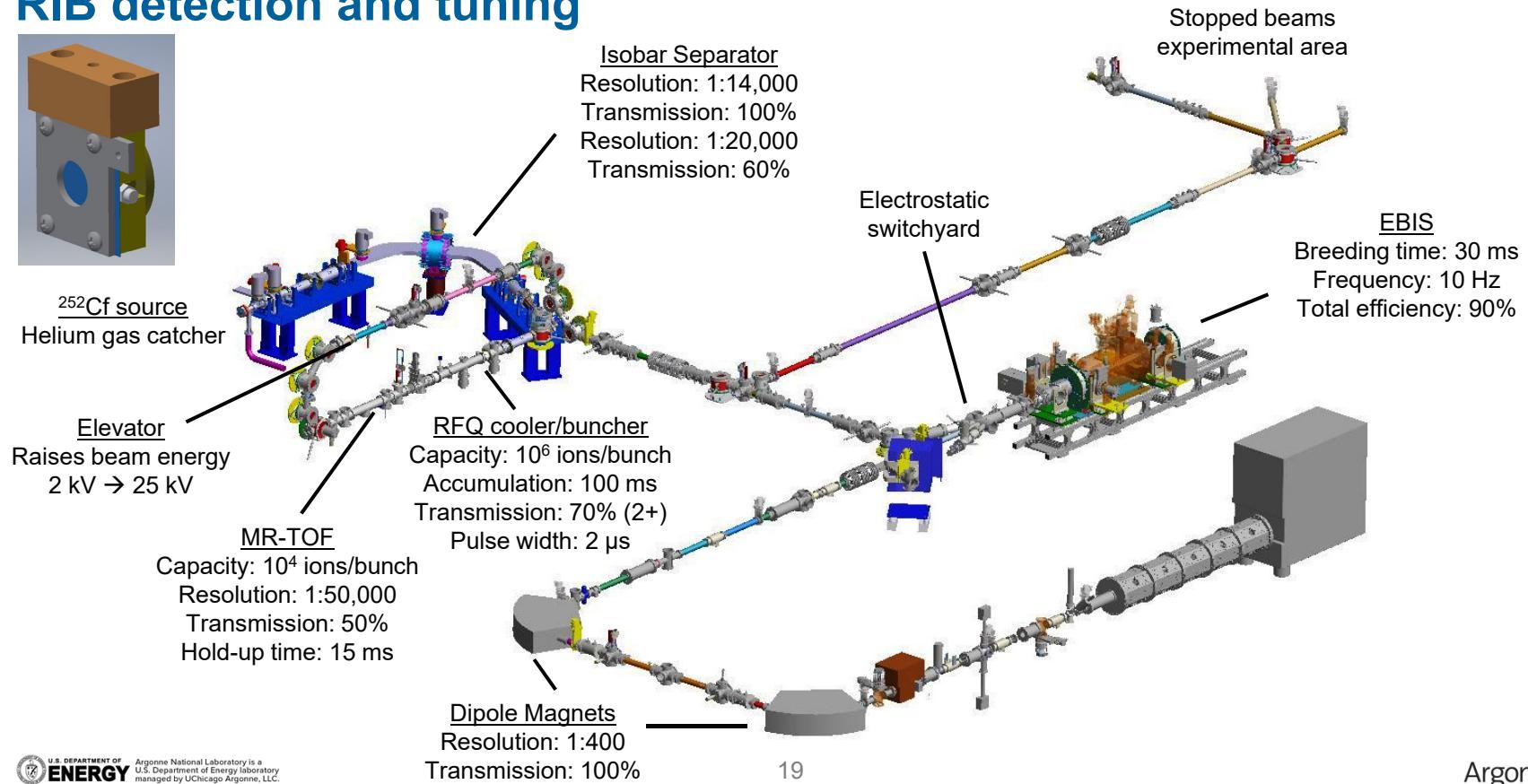
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EBIS CHARGE BREEDING CYCLE



EBIS CHARGE BREEDING CYCLE

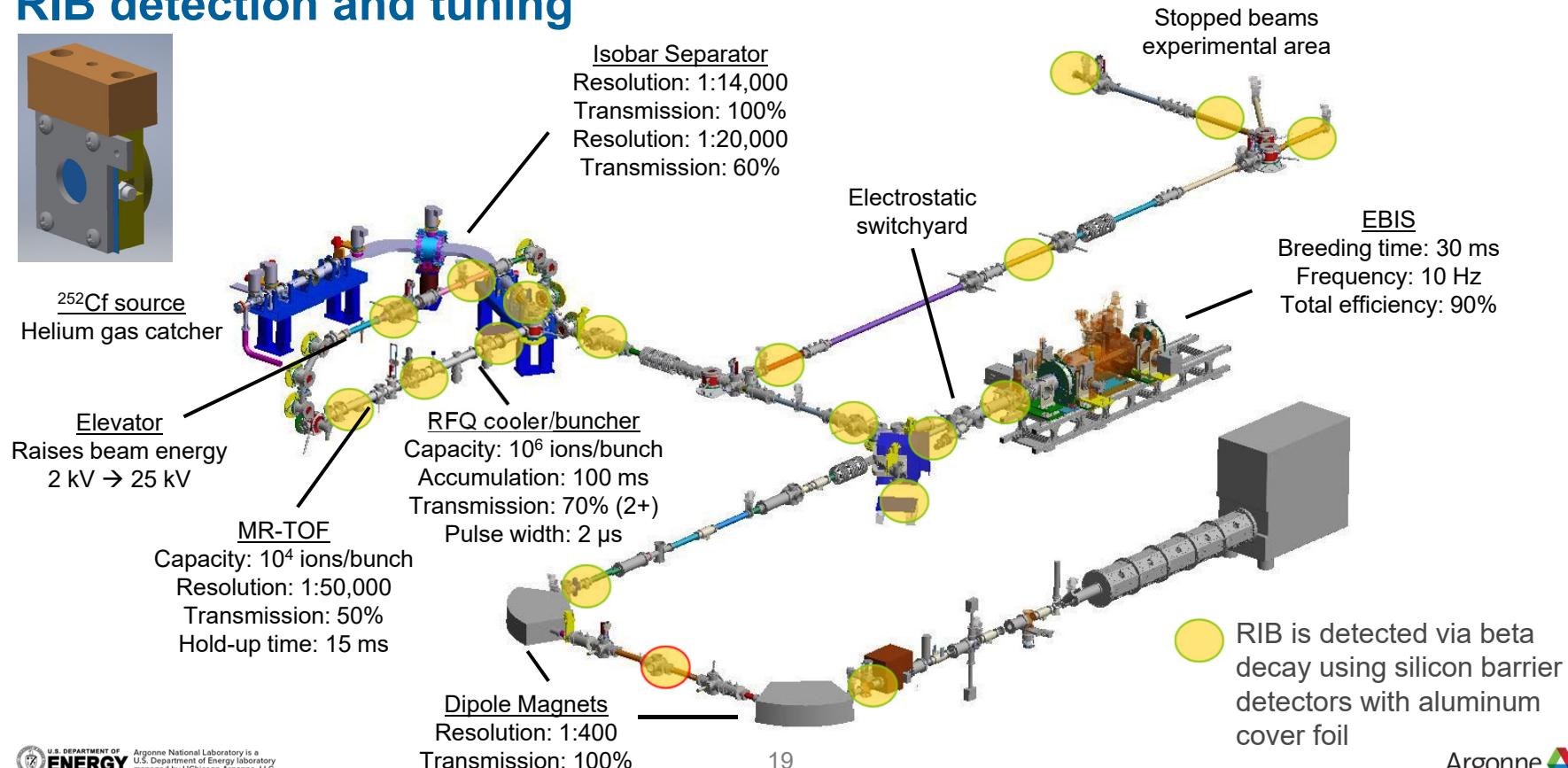
RIB detection and tuning



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EBIS CHARGE BREEDING CYCLE

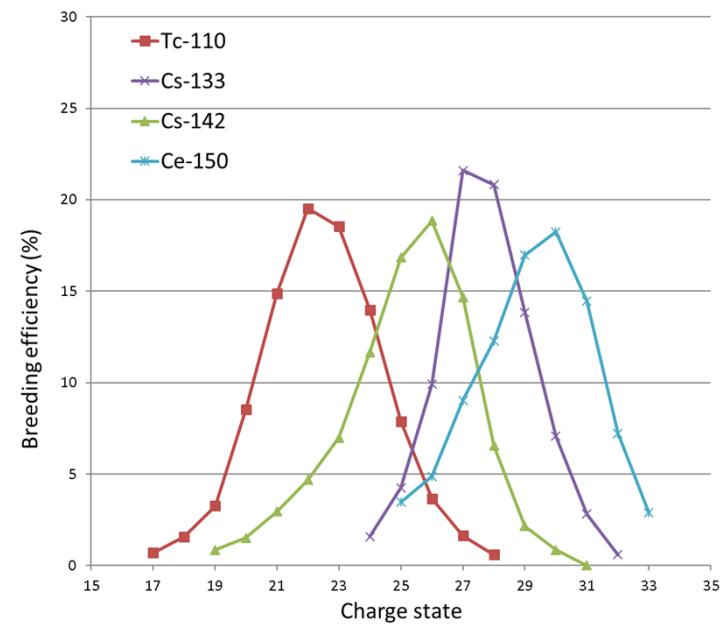
RIB detection and tuning



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EBIS CHARGE BREEDER PERFORMANCE

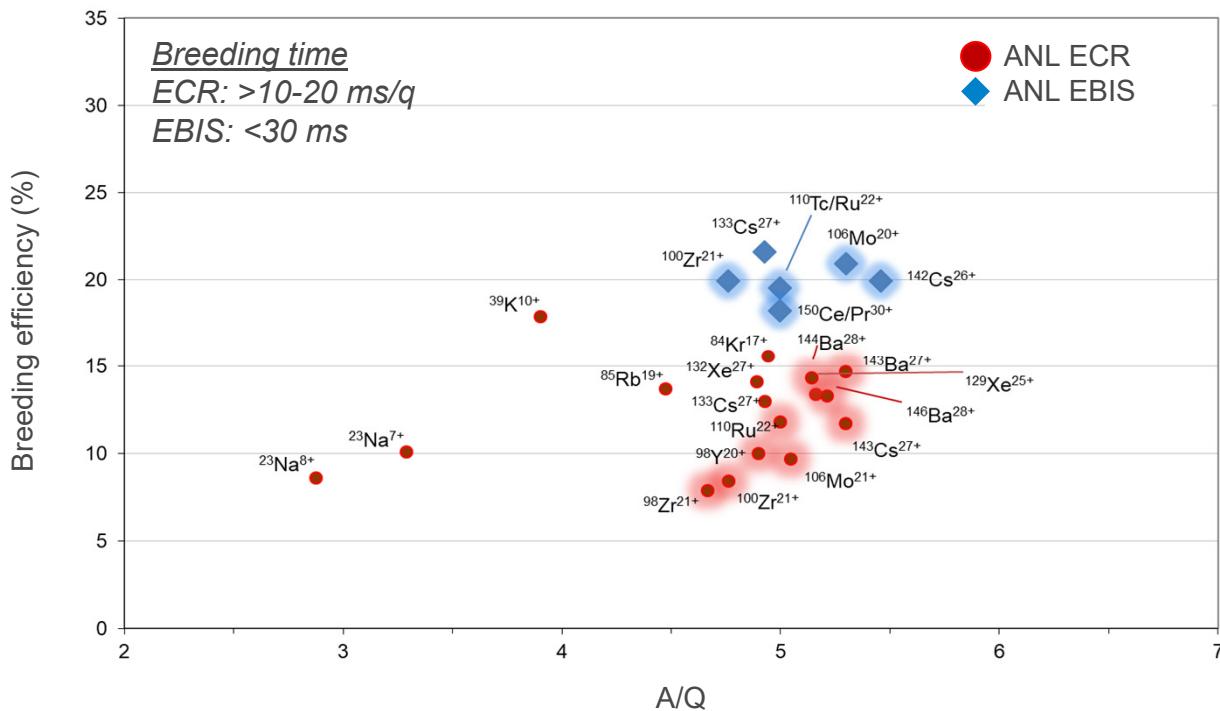
- Set up EBIS with ^{133}Cs pilot beam and adjust trap timing and injection steering for RIB
- Have produced 11 radioactive species in last six months
 - Average single charge state efficiency
 - EBIS only: 19%
 - RFQ-CB + EBIS: 13%
 - Rep rate: 10 Hz
 - Breeding time: 18-26 ms
 - Injected pulse width: 10 μs
 - Extracted pulse width: 1-3 ms



Breeding efficiency charge state distributions for selected species

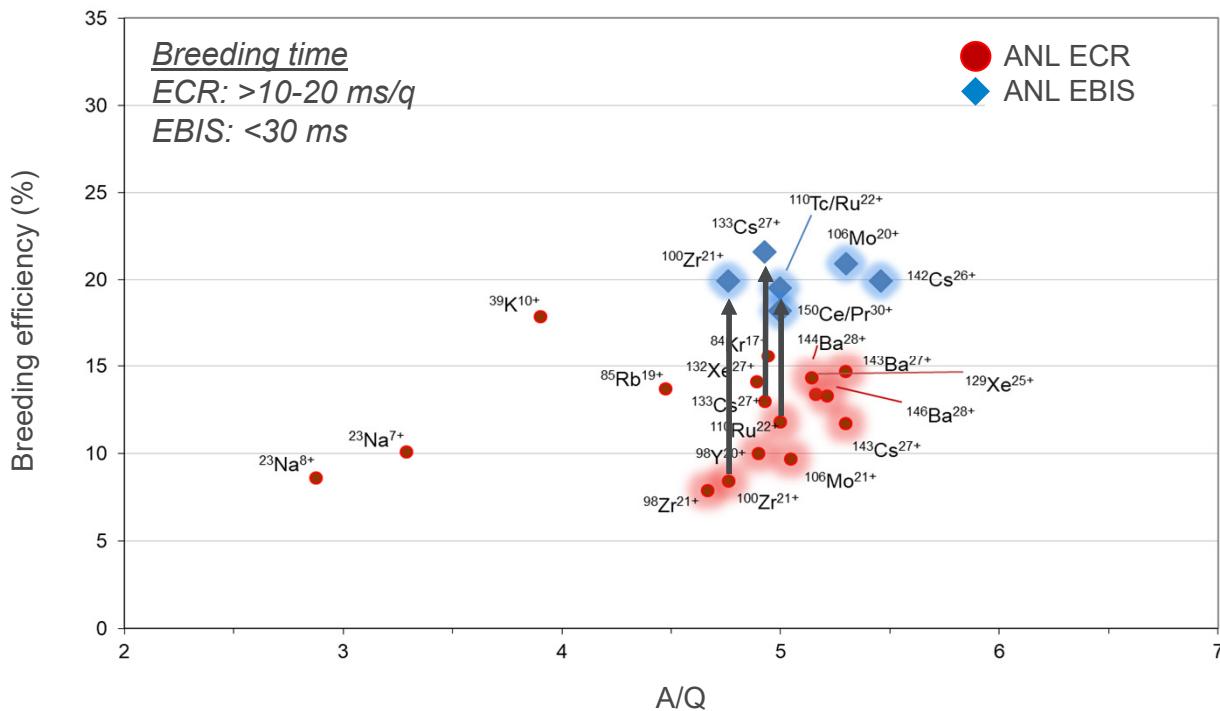
EBIS CHARGE BREEDER EFFICIENCY

Compared to ANL ECR charge breeder



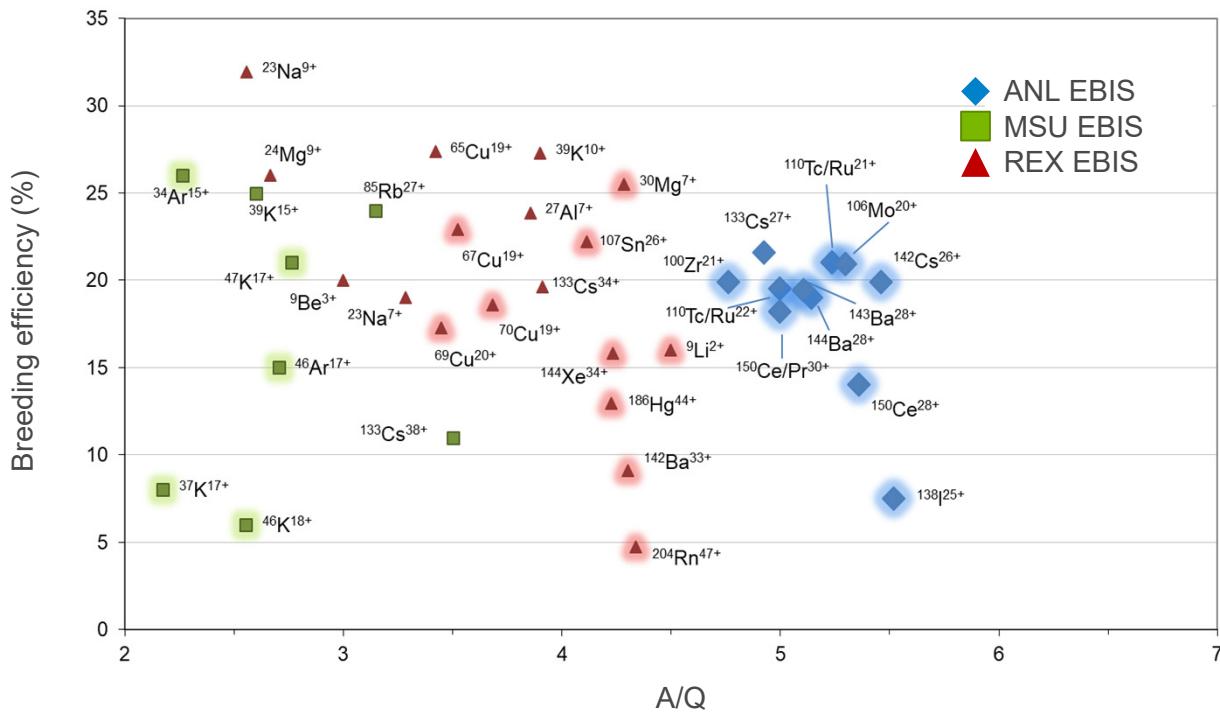
EBIS CHARGE BREEDER EFFICIENCY

Compared to ANL ECR charge breeder



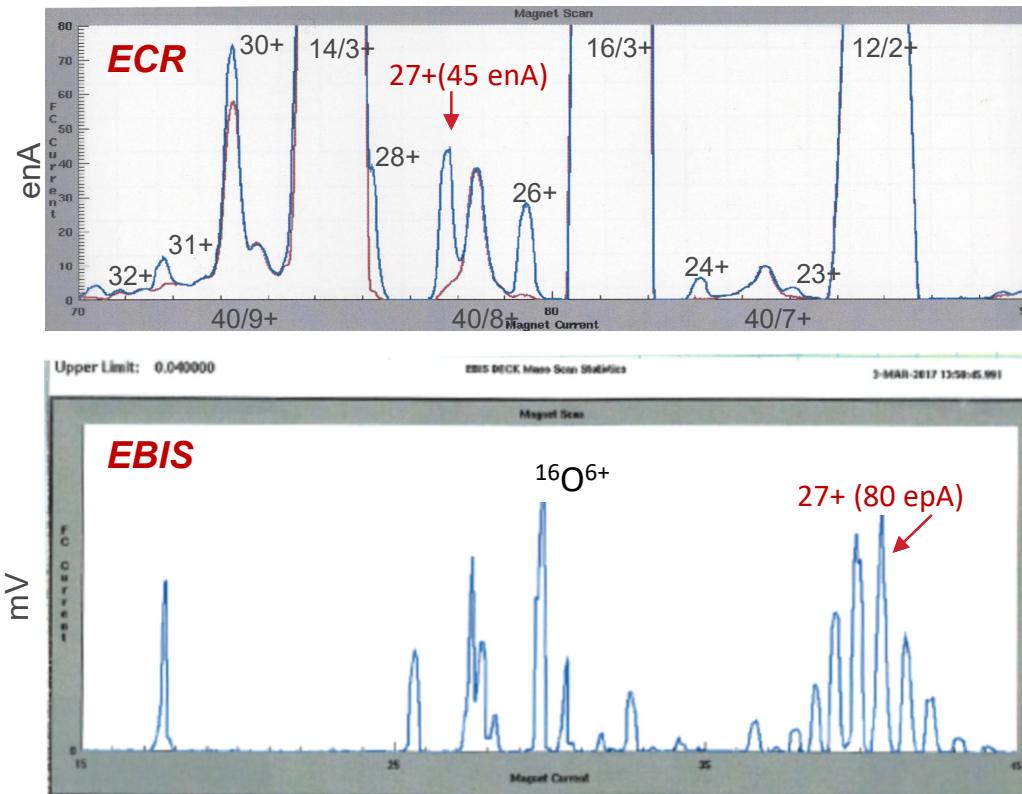
EBIS CHARGE BREEDER EFFICIENCY

EBIS ONLY



STABLE BACKGROUND – 133Cs

ECR vs. EBIS



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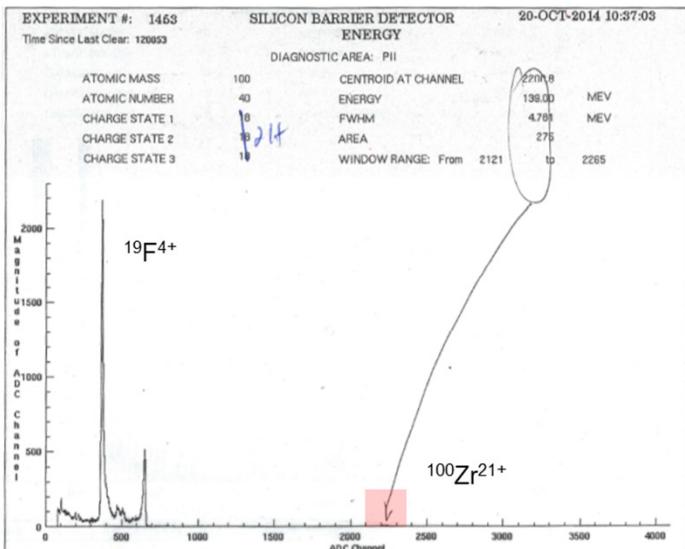
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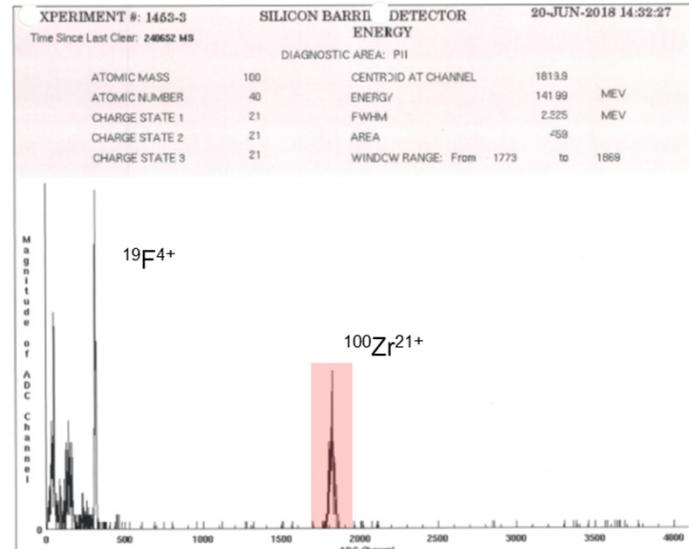
BEAM BACKGROUND – 100Zr

ECR vs. EBIS



Beam from ECR charge breeder

$^{100}\text{Zr}^{21+}$: 2400 pps (beta)
 Stable background rate: 2400 Hz
 RIB: <0.01% of total beam current



Beam from EBIS charge breeder

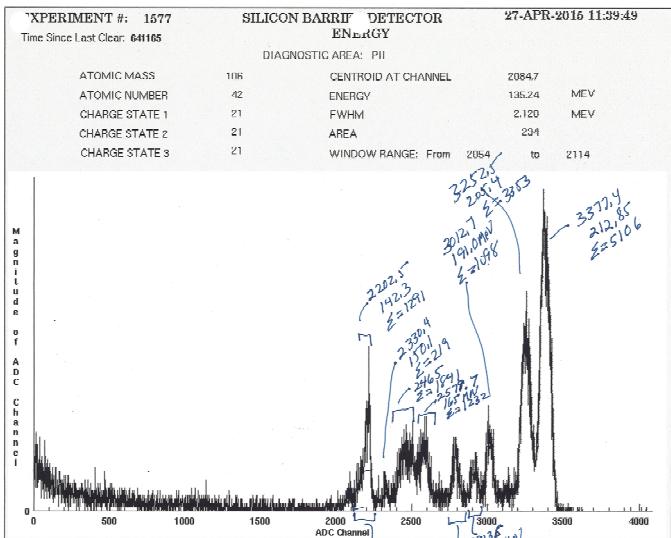
$^{100}\text{Zr}^{21+}$: 300 pps (beta)
 Stable background rate: 1.6 Hz
 RIB: 55% of total beam current



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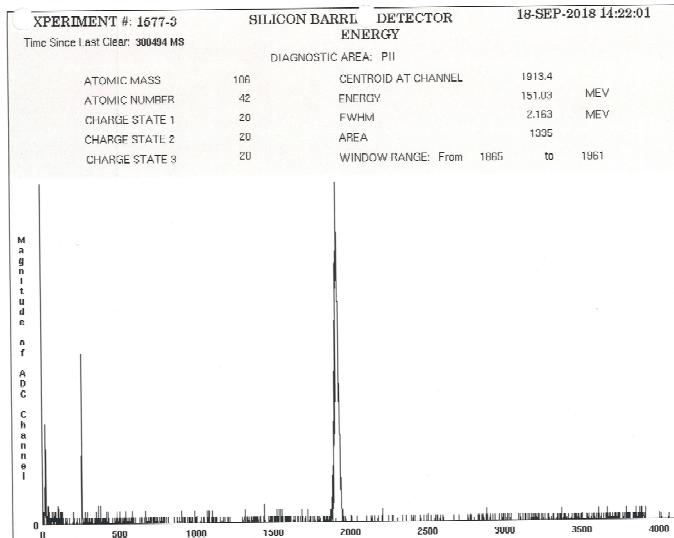
BEAM BACKGROUND – 106Mo

ECR vs. EBIS



Beam from ECR charge breeder

$^{106}\text{Mo}^{21+}$: 6000 pps (beta)
 Stable background rate: 25 Hz
 RIB: <0.01% of total beam current



Beam from EBIS charge breeder

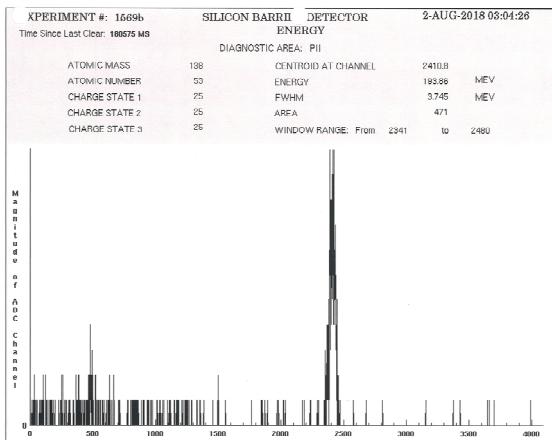
$^{106}\text{Mo}^{20+}$: 5500 pps (beta)
 Stable background rate: 0.3 Hz
 RIB: 94% of total beam current



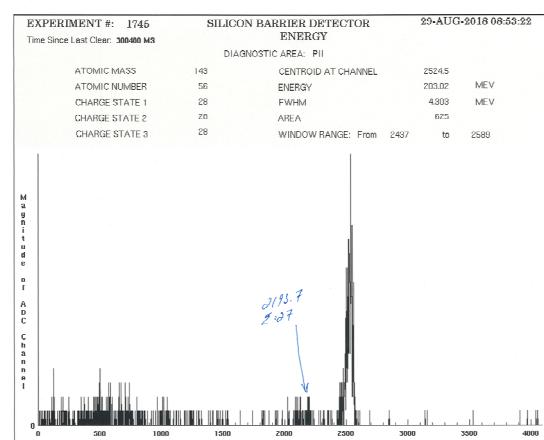
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BEAM BACKGROUND

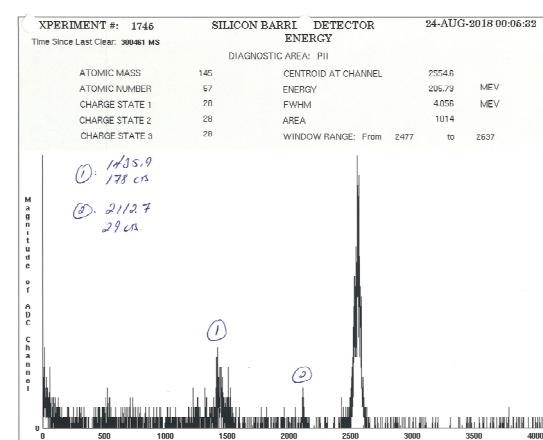
EBIS only



$^{138}I^{25+}$: 1300 pps (beta)
Stable background rate: 0.2 Hz
RIB: 92% of total beam current



$^{143}Ba^{28+}$: 6800 pps (beta)
Stable background rate: 0.1 Hz
RIB: 96% of total beam current

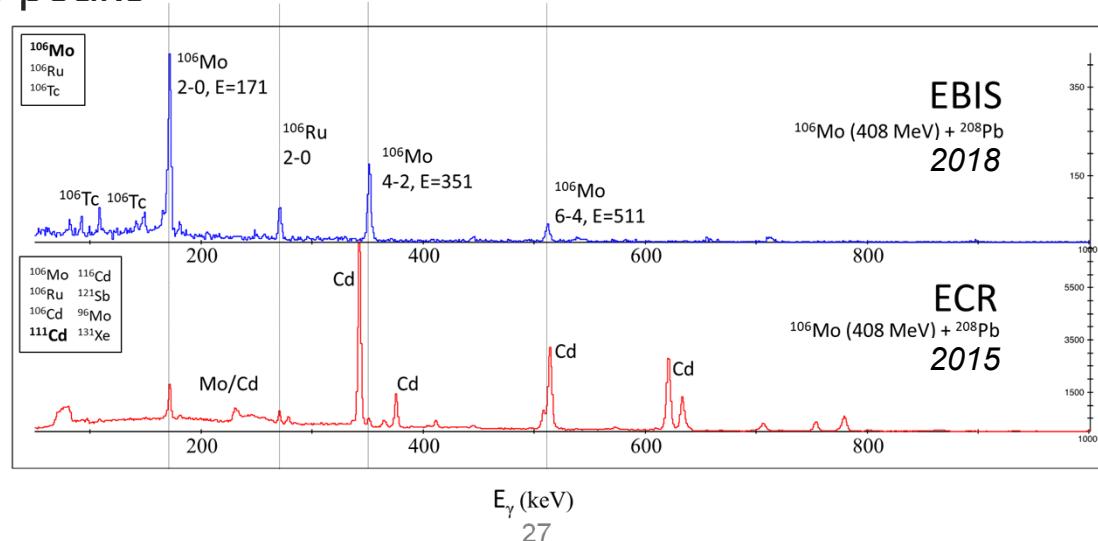


$^{145}Ba^{28+}$: 7000 pps (beta)
Stable background rate: 0.7 Hz
RIB: 83% of total beam current

EFFECT ON EXPERIMENTAL EFFICIENCY

Quality of beam on target

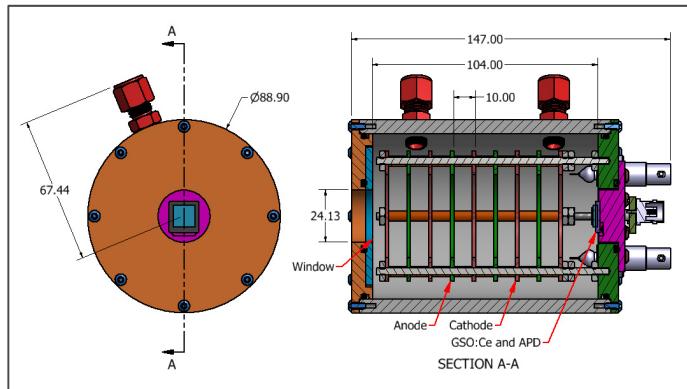
- Had performed a ^{106}Mo experiment with ECR-CB in 2015
- Repeated the same experiment with EBIS-CB in 2018
- Improved signal-to-noise ratio
- Less spurious peaks



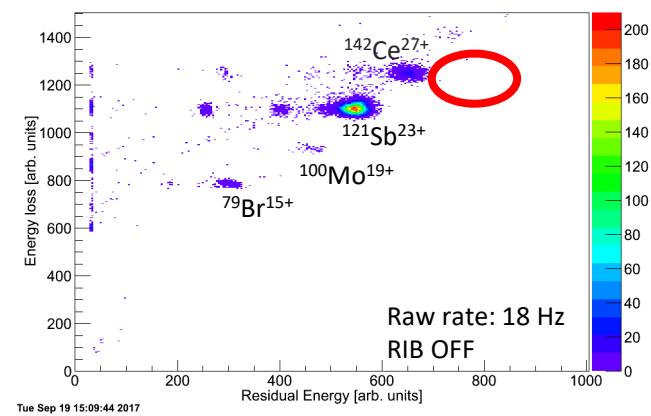
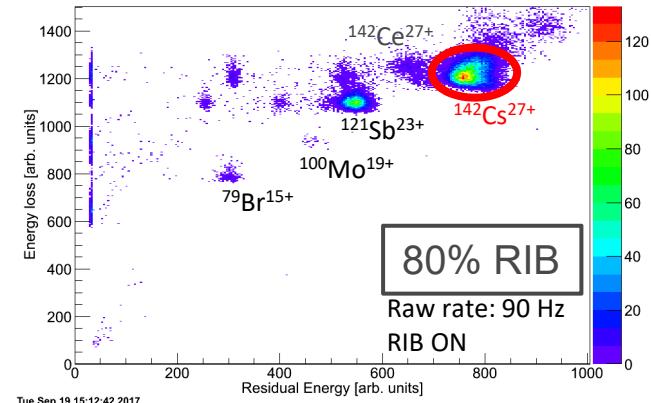
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RIB DETECTION



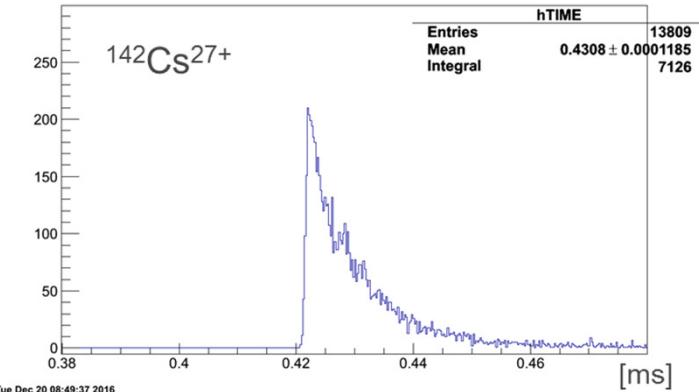
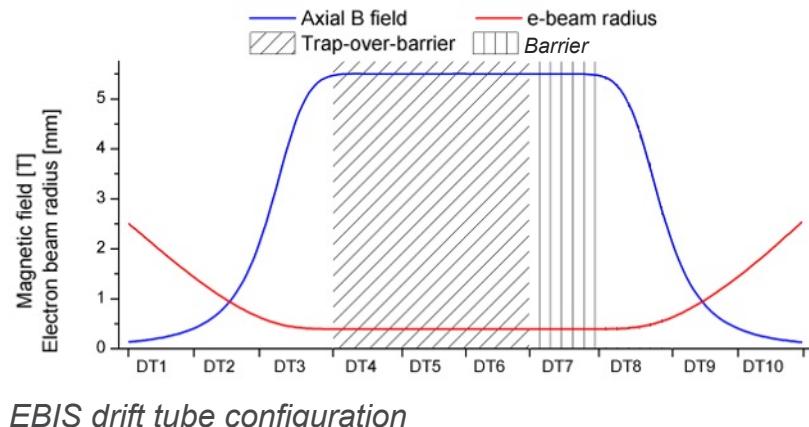
- Fast and compact gas ionization chamber
 - Direct measurements of CARIBU RIBs for tuning and identification
 - Avoids time lag inherent to beta decay detection method
 - Can be positioned at many places along accelerator
 - Prototype performance limited at rate of 2×10^4 ions/sec



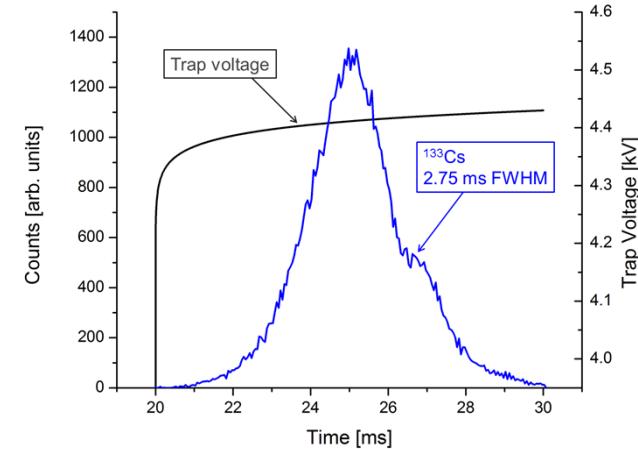
BEAM EXTRACTION

Fast and slow modes

- Fast – barrier lowering
 - Drop DT7
- Slow – trap over barrier
 - DT7 stays fixed
 - Raise DTs 4, 5, 6



Fast extraction

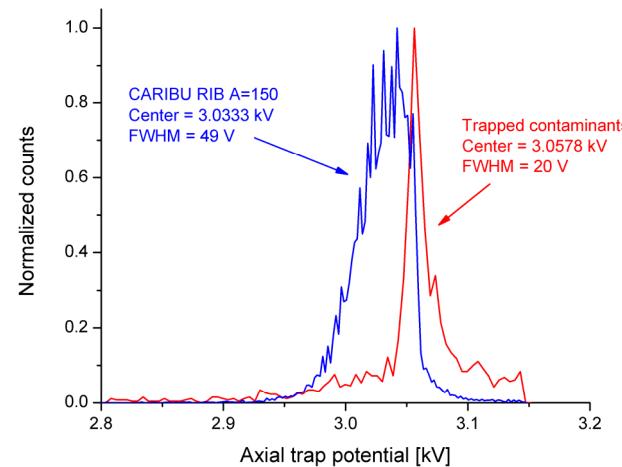
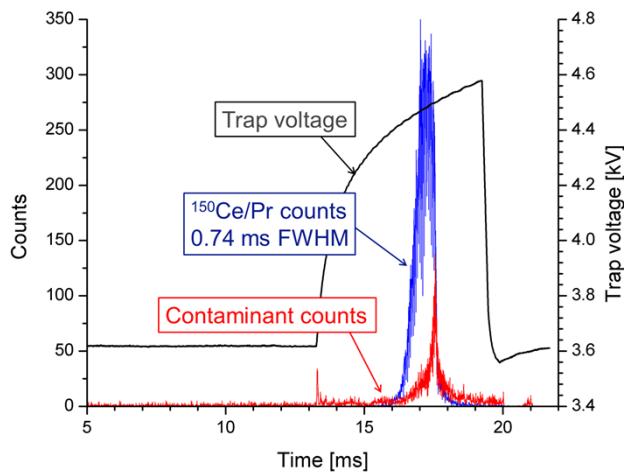


Slow extraction

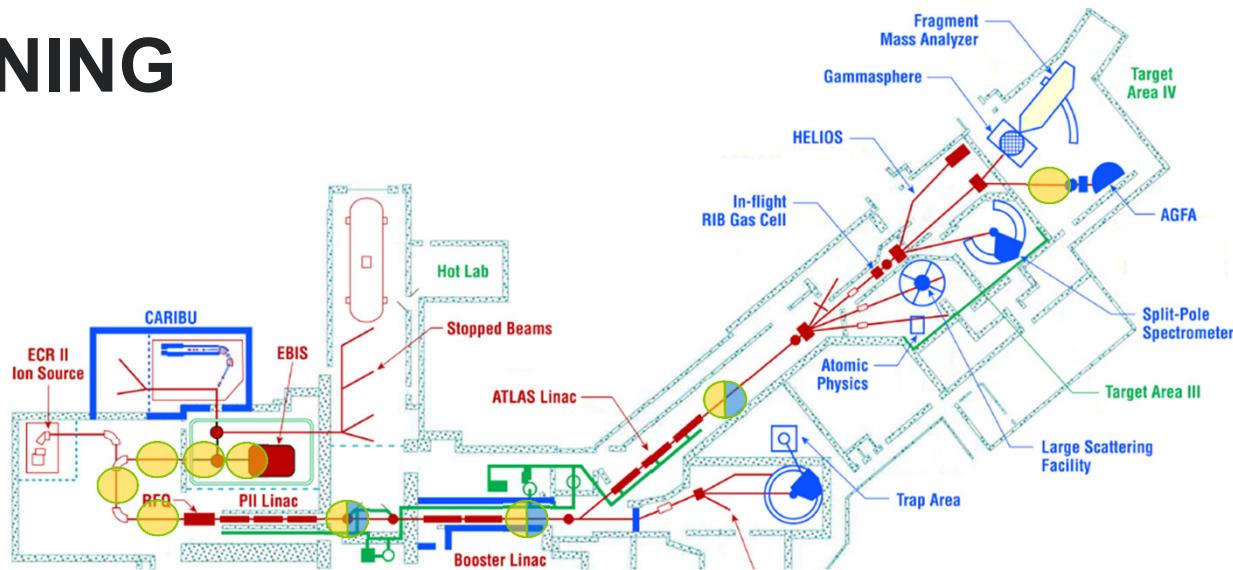
BEAM EXTRACTION

Slow mode – trap over barrier

- Observed beam with gas ionization chamber – mass and timing information
- Arrival time correlated to trap voltage ramp
- Continuous extraction of light species which are ionized outside of the trap
- Distinct energies of injected and residual ions released from the trap

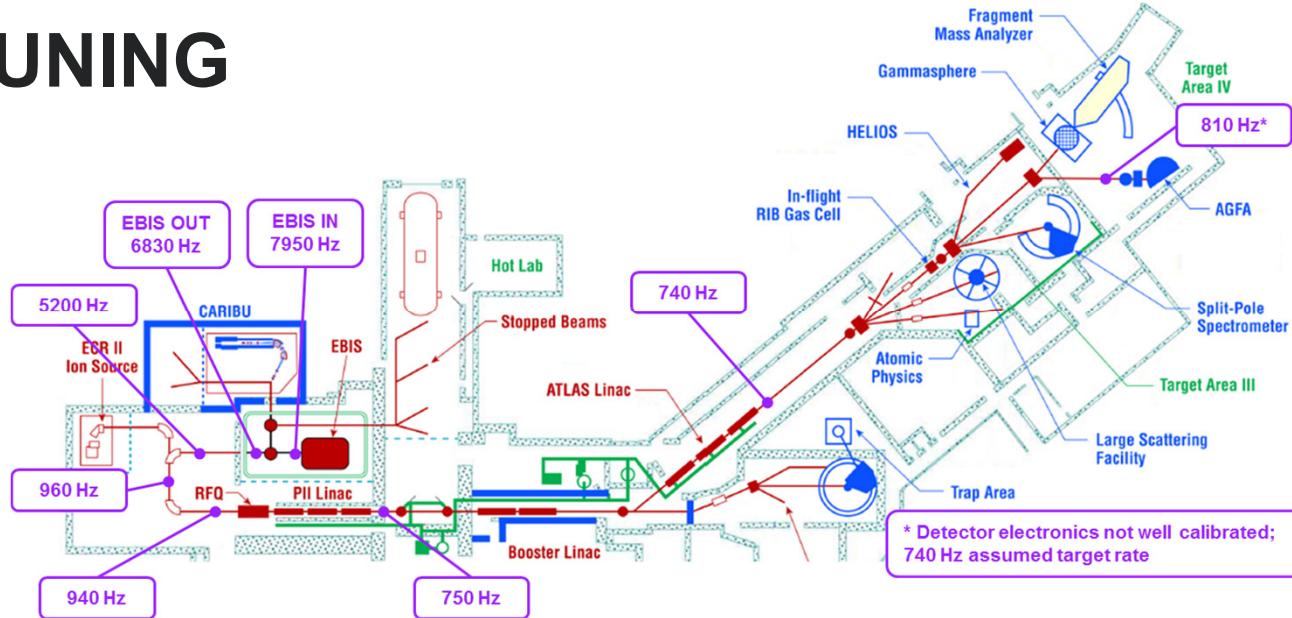


RIB TUNING



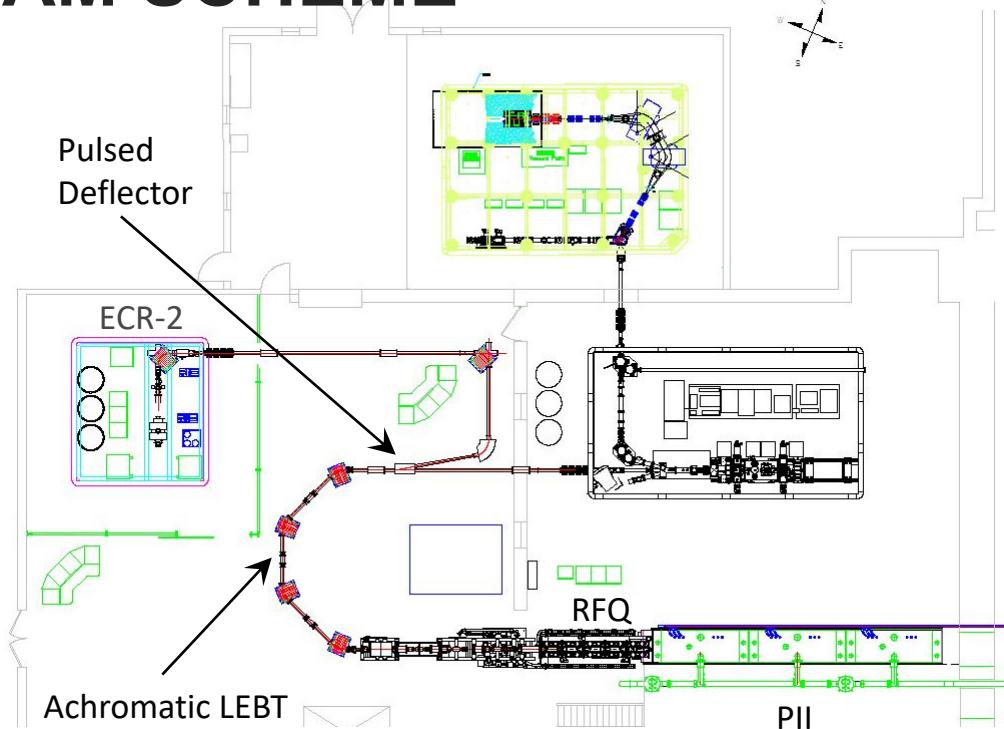
- Tune machine with stable pilot beam of $^{133}\text{Cs}^{26+}$
- Pilot beam measured on faraday cups
 - Typically 30-50 epA
- Stop Cs⁺ beam and inject low charge state RIB into EBIS
- Scale entire machine over to RIB of interest
- Beta rates measured with silicon barrier detectors with aluminum cover foils

RIB TUNING



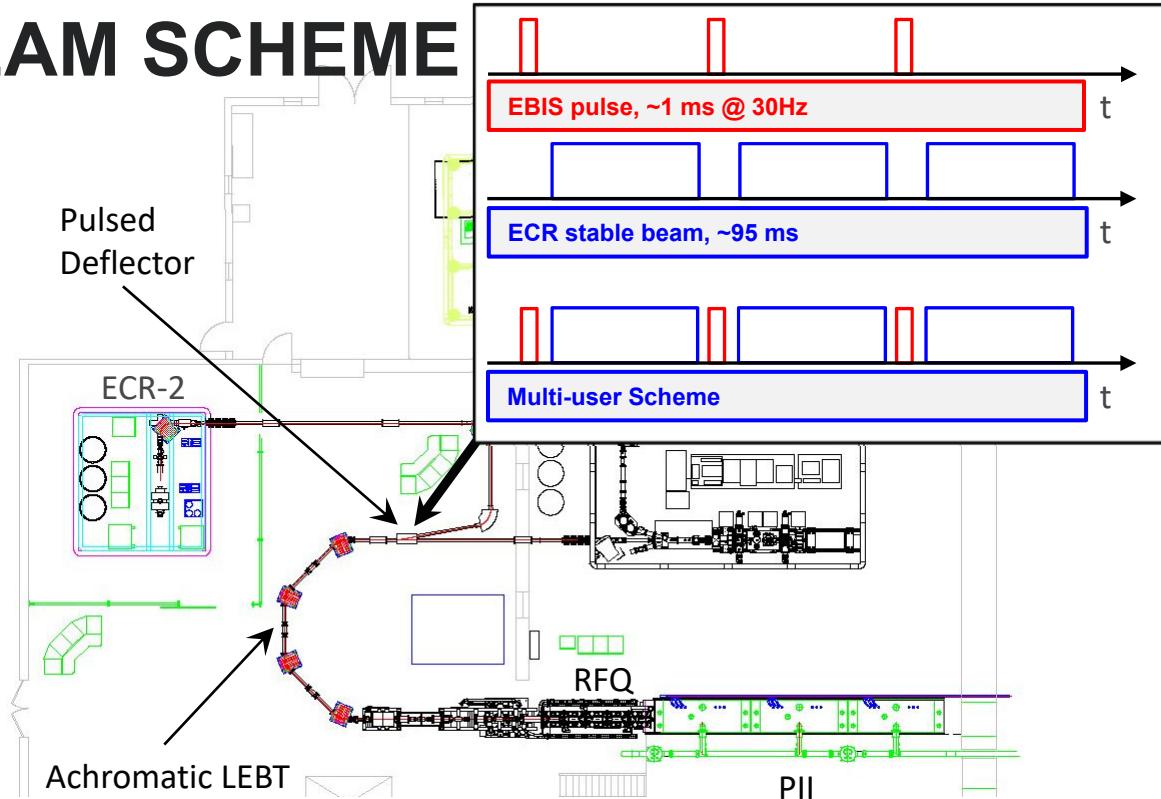
- Stable pilot beam of $^{133}\text{Cs}^{26+}$ with transmission of 73%
- Transmission with $^{150}\text{Ce}/\text{Pr}^{29+}$ was 77%
- EBIS IN-to-target efficiency: $740/7950 = 9.3\%$

MULTI-BEAM SCHEME



- The simultaneous acceleration of two beam species
 - One stable from the ECR and one radioactive from CARIBU-EBIS
 - A/q required to be within 1% of each other

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ACKNOWLEDGEMENTS

This is the work of many people...

J. Clark, R. Pardo, G. Savard – ANL CARIBU

C. Dickerson, S.A. Kondrashev, P.N. Ostroumov, E. Beebe,
A. Pikin, C. Peters, M. Powers, D. Santiago-Gonzalez,
S. Sharamentov, A. Barcikowski, G. Cherry
– EBIS development

B. Mustapha – Beam optics